

## Amendments to the Specification

Please amend the title as follows:

~~PVD Targets Comprising Copper in Ternary or Higher Order Mixtures and Methods of~~  
~~Forming Copper-Containing PVD Targets~~ and Methods for Their Manufacture

At page 1, prior to the Field of the Invention section, please enter the following new paragraph.

### RELATED PATENT DATA

This application claims priority to Patent Cooperation Treaty application Serial No. PCT/US2004/027090, which was filed August 20, 2004, and which claims priority to U.S. Provisional Application Serial No. 60/497,149, which was filed August 21, 2003.